

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/531,321	EBINUMA, HIROYUKI	
	Examiner	Art Unit	
	Qiuwen Mi	1655	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
PG-Pub	searched	1/16/2008	QM